

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q81007

Yasushi OKUBO, et al.

Appln. No.: 10/820,785

Group Art Unit: 1756

Confirmation No.: 8719

Examiner: Stephen D. ROSASCO

Filed: April 9, 2004

For: METHOD OF MANUFACTURING A PHOTOMASK, AND PHOTOMASK BLANK  
**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three month(s), extending the time for responding to the Office Action of January 22, 2007 to July 22, 2007.

The statutory fee of \$1020.00 is being charged to Deposit Account No. 19-4880 via EFS Payment Screen. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

*/Alan J. Kasper/*

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Date: July 23, 2007